



**MS AF**  
REPLY UNDER  
37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 1765

PATENT  
0033-0701P

IN THE U.S. PATENT AND TRADEMARK OFFICE

OK to enter

Applicant: Tetsuya NAKABAYASHI et al. Conf.: 1937  
Appl. No.: 09/813,152 Group: 1765  
Filed: March 21, 2001 Examiner: L. Vinh  
For: SUSCEPTOR AND SURFACE PROCESSING  
METHOD

LV  
4/3/2004

REPLY UNDER 37 C.F.R. § 1.116

**MS AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

March 29, 2004

Sir:

In reply to the final Office Action dated January 29, 2004, the following remarks are respectfully submitted in connection with the above-identified application.

This reply includes: Remarks.